

03560.002647.



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

2811
#20 / IDS
10-23-03
R. H. H.

In re Application of:)
: Examiner: S. Hu
Tohru DEN, et al.)
: Group Art Unit: 2811
Application No.: 09/666,605)
: Filed: September 20, 2000)
: For: STRUCTURE HAVING PORES,) October 17, 2003
: DEVICE USING THE SAME, AND)
: MANUFACTURING METHODS)
: THEREFOR)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

The Masuda article is discussed at page 4 of the specification and might be deemed relevant for the reasons given there. The other listed document is an English-language translation of JP 11-200090, cited in the Information Disclosure Statement dated September 19, 2000. A copy of the translation was attached to the Supplement to

Amendment dated December 31, 2002.

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FORMAL MATTERS

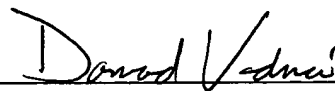
We also enclose a check for the required fee of \$180.00 to cover the Information Disclosure Statement under 37 C.F.R. 1.97(c)(2). The Commissioner is hereby authorized to charge any fee which may be required in connection with this paper to Deposit Account No. 06-1205. A duplicate of this paper is enclosed for that purpose.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that the enclosed Form PTO-1449 be returned with the next official communication indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,



Attorney for Applicants

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DEV/cmv

FORM PTO 1449 (modified)

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICELIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)ATTY DOCKET NO.
03560.002647.APPLICATION NO.
09/666,605APPLICANT
Tohru DEN, et al.FILING DATE
September 20, 2000GROUP
2811Date submitted to the PTO: **October 17, 2003**

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

	Masuda, "Metal nanohole array having high regularity formed of anodized alumina," KOTAIBUTSURI (Solid State Physics) 31, vol. 31, no. 5, pp. 493-499 (1996).
	English-language translation of JP 11-200090.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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